

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Nobuhiko HAYASHI, et al.

Serial No.: 10/084,050

Group Art Unit: 2812

Filed: February 28, 2002

Examiner: D. Le

For:

NITRIDE-BASED SEMICONDUCTOR ELEMENT AND METHOD OF FORMING

NITRIDE-BASED SEMICONDUCTOR

## PETITION FOR EXTENSION OF TIME

Commissioner for Patents Washington, DC 20231

Sir:

It is respectfully requested that the time for response to the Office Action dated October 2, 2002, now due to expire November 2, 2002, be extended for one month(s) and set to expire on December 2, 2002.

Please charge the extension fee of \$110.00 to Deposit Account No. 500417. Please charge any additional fees or credit any overpayment to Deposit Account No. 500417.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

Registration No. 26,106

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